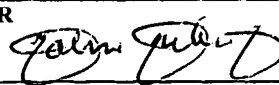


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78	E	5,078,479	01/07/1992	Vuilleumier	359	290	04/18/1991
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78	J	5,500,761	03/19/96	Goossen, et al.	359	290	01/27/94
78	K	5,654,819	08/05/97	Goossen, et al.	359	291	01/07/95
78	L	5,659,418	08/19/97	Yurke	359	290	02/05/96
78	M	5,684,631	11/04/1997	Greywall	359	565	05/13/1996
78	N	5,661,592	08/26/1997	Bornstein, et al.	359	291	01/07/95
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73	D	5,825,528	10/20/1998	Goossen	359	291	12/26/95
74	E	5,835,255	11/10/1998	Miles	359	291	05/05/94
75	F	5,841,579	11/24/1998	Bloom, et al.	359	572	06/07/95
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78	I	5,870,221	02/09/1999	Goossen	359	290	07/25/97
79	J	5,914,804	06/22/1999	Goossen	359	291	01/28/98
80	K	5,943,155	08/24/1999	Goossen	359	247	08/12/98
81	L	5,943,158	08/24/1999	Ford, et al.	359	295	05/05/98
82	M	5,943,454	08/24/1999	Aksyuk, et al.	385	22	08/15/97
83	N	5,949,571	09/07/1999	Goossen, et al.	359	291	07/30/98

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88	C	5,986,796	11/16/1999	Miles	359	260	11/05/1996
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88	E	6,002,513	12/14/1999	Goossen, et al.	359	291	06/22/1998
88	F	6,046,840	04/04/2000	Huibers	359	291	09/24/1998
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78	D	2002/0081070 A1	06/27/2002	Tew	385	39	11/13/2001
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78	F	6,439,728 B1	08/27/2002	Copeland	359	515	08/28/2001
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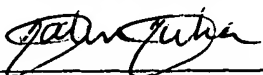
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